

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Yasuo KOBAYASHI, et al.

SERIAL NO: 09/736,147

GAU: 1763

FILED: December 15, 2000

EXAMINER: T. D. Dang

PROCESSING METHOD AND APPARATUS FOR REMOVING OXIDE FILM

REQUEST FOR EXTENSION OF TIME  
UNDER 37 C.F.R. 1.136

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

It is hereby requested that a **one** month extension of time be granted to April 17, 2003 for

- ☒ filing a response to the Official Action dated: December 17, 2002
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☐ filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐ Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$110.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

04/17/2003 HUJONG1 00000074 09736147

01 FC:1251

110.00 OP

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

Norman F. Oblon

Registration No. 24,618

Harris A. Pitlick

Registration No. 38,779



22850

Tel. (703) 413-3000  
Fax. (703) 413-2220  
(OSMMN 10/01)

15  
RECEIVED  
APR 22 2003  
GROUP 1700

